

## IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: HIRANO, Mitsuhiro

Application No.: 08/813,200

Filed: March 7, 1997

For: SUBSTRATE PROCESSING APPARATUS



Group: 1104

Examiner:

STATUS INQUIRYAssistant Commissioner for Patents  
Washington, D.C. 20231

October 29, 1998

Sir:

Please advise the undersigned as to the status of the above-identified application.

A duplicate copy of the present Status Inquiry is attached hereto. It is respectfully requested that the duplicate copy be marked appropriately to indicate the status of the above-identified application, and returned to the undersigned as soon as possible.

Please call the undersigned at (703) 205-8000 if there are any questions with regard to the present request.

RECEIVED  
NOV 03 1998  
GROUP 2100

Respectfully submitted,

BIRCH, STEWART, KOLASCH &amp; BIRCH, LLP

By: 

ROBERT V. RACUNAS

Reg. No. 43,027

P. O. Box 747

Falls Church, Virginia 22040-0747

/dlg

\_\_\_\_\_ Awaiting Action from Patent Office Examiner:  
\_\_\_\_\_

\_\_\_\_\_ Awaiting Decision by Board of Appeals.

\_\_\_\_\_ Application allowed on \_\_\_\_\_.

\_\_\_\_\_ Abandoned per \_\_\_\_\_.

\_\_\_\_\_ Other \_\_\_\_\_  
\_\_\_\_\_